



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 1952

SERIAL NUMBER 10/796,507	FILING DATE 03/09/2004  RULE	CLASS 134	GROUP ART UNIT 1746	ATTORNEY DOCKET NO. SAM-0526
-----------------------------	---------------------------------------	--------------	------------------------	------------------------------------

## APPLICANTS

Ki Hwan Park, Suwon-Si, KOREA, REPUBLIC OF;

Jong Kook Song, Suwon-Si, KOREA, REPUBLIC OF;

Mo Hyun Cho, Suwon-si, KOREA, REPUBLIC OF; Sung-Ho Cho, Hwasung-Kun, KOREA, REPUBLIC OF;

Sun Jae Lee, Suwon-Si, KOREA, REPUBLIC OF;

Pyung Ho Lim, Osan-Si, KOREA, REPUBLIC OF;

Dong Wook Cho, Dong-Gu, KOREA, REPUBLIC OF;

## \*\* CONTINUING DATA \*\*\*\*\*

None ZE

## \*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 03-75573 10/28/2003

ZE

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/25/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance ZE Examiner's Signature Initials	STATE OR COUNTRY KOREA, REPUBLIC OF	SHEETS DRAWING 8	TOTAL CLAIMS 38	INDEPENDENT CLAIMS 4
--	--	---	------------------------	-----------------------	----------------------------

## ADDRESS

Anthony P. Onello, Jr.  
 MILLS & ONELLO LLP  
 Suite 605  
 Eleven Beacon Street  
 Boston, MA  
 02108

## TITLE

System for rinsing and drying semiconductor substrates and method therefor